

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Byung-Hee KIM, et al.

Art Unit: 2822

Serial No. 10/035,257

Examiner: M. Guerrero

Filed: January 4, 2002

Confirmation No. 2929

For: METHOD OF FABRICATING METAL
LINES IN A SEMICONDUCTOR DEVICE

REQUEST FOR APPROVAL OF DRAWING CHANGE

Commissioner for Patents
Washington, D.C. 20231

Sir:

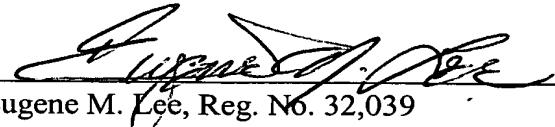
Applicants hereby request approval of the additions and deletions as noted in red on the attached one sheet of drawing.

Applicants have also provided one sheet of drawing incorporating the changes.

Respectfully submitted,

LEE & STERBA, P.C.

Date: October 8, 2003


Eugene M. Lee, Reg. No. 32,039
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Deposit Account Charge Authorization

If fee payment is enclosed, this amount is believed to be correct. However, the Director is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 5-01645.

Any additional fee(s) necessary to effect the proper and timely filing of the above-paper may also be charged to Deposit Account No. 5-01645.

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